

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : Confirmation No.:
Applicant : **Meimei Z. Tidrow, et al.**
Filed : **Herewith**
TC/A.U. :
Examiner :

Docket : **ARL 98-68D**

Customer No. : **21364 U.S. Army Research Laboratory**

For: Method of Fabricating a Colossal Magneto-Resistive Detector Using a Thin Film Transfer Method

U.S. Patent and Trademark Office
2011 South Clark Place
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Sir:

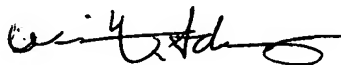
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In accordance with 37 CFR §§1.56, 1.97 and 1.98 applicants hereby call to the attention of the Examiner the references cited on the PTO-SB/08A and PTO-SB/08B (substitute for Form 1449/PTO1449), attached hereto.

These citations do not constitute an admission that the references are relevant or material to the claims. They are cited only as constituting the closest art of which the Applicants are aware.

Respectfully submitted,

22 MARCH 2004
DATE


William V. Adams
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(Use as many sheets as necessary)

Complete if Known

Application Number

Filing Date

First Named Inventor

Meimei Z. Tidrow

Art Unit

Examiner Name

Attorney Docket Number

ARL 98-68D

Sheet

1

of

2

U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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Signature**

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number			
		Filing Date			
		First Named Inventor		Meimei Z. Tidrow	
		Art Unit			
		Examiner Name			
Sheet	2	of	2	Attorney Docket Number	ARL 98-68D

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	AF	A. GOYAL, et al. "Material Characteristics of Perovskite Manganese Oxide Thin Films for Biometric Applications, Applied Physics Letters 71, October 27, 1997, pgs 2535-2537	
	AG	Z. TRAJANOVIC, et al. "Growth of Colossal Magnetoresistance Thin Films on Silicon," Applied Physics Letters 69, August 12, 1998, pgs. 1005-1007	

Examiner Signature		Date Considered	
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